

NOV 14 2007

Customer No.: 31561
Docket No.: 12739-US-PA
Application No.: 10/710,698

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: SALZMAN, KOURTNEY R

Group Art Unit: 4128

In re PATENT APPLICATION of

Applicants : Chen et al.

Serial No. : 10/710,698

Filed : 2004/7/29

For : PHYSICAL VAPOR
DEPOSITION PROCESS AND
APPARATUS THEREFORAMENDMENT

Attorney Docket: 12739-US-PA

"The Commissioner is authorized to charge the fees indicated in the transmittal letter and any other fees required in connection with the filing of this paper to account No. 50-2620 (Order No.: 12739-US-PA)."

RESPONSE TO RESTRICTION REQUIREMENT

United States Patent and Trademark Office
Customer Service Window
Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Dear Sir:

The Office Action mailed on October 15, 2007 has been carefully considered.

In response thereto, please enter the amendments as below and consider the following remarks.

Customer No.: 31561
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AMENDMENT

In the title:

~~PHYSICAL VAPOR DEPOSITION PROCESS AND APPARATUS THEREFOR~~

PHYSICAL VAPOR DEPOSITION